Silicon Wafer Japan TC Chapter Meeting

In conjunction with SEMICON Japan 2026

Thursday, December 10, 2026

Room 905, TFT Building East Wing 9F, Tokyo, Japan/ Official Virtual TC Chapter Meeting (Hybrid)

9:00 AM － 12:00 PM JST

AGENDA

1 Welcome/Call to Order

1.1 Introduction

1.2 Required Meeting Elements

1.3 Agenda Review

2 Review of Previous Meeting Minutes

3 Liaison Report

3.1 Japan Regional Standards Committee (JRSC)

3.2 Global Coordinating Subcommittee (GCS)

3.3 Europe TC Chapter

3.4 North America TC Chapter

4 Staff Report

5 Ballot Review

5.1 Document #7496, Line Item Revision to SEMI M90-0821, TEST METHOD FOR BULK MICRO DEFECT DENSITY AND DENUDED ZONE WIDTH IN ANNEALED SILICON WAFERS BY OPTICAL MICROSCOPY AFTER PREFERENTIAL ETCHING

5.2 Document #7439, Auxiliary Information: BACKGROUND, RATIONALE, AND APPLICATION GUIDELINES FOR SEMI M95:TEST METHOD FOR NET CARRIER DENSITY AND RESISTIVITY OF SILICON EPITAXIAL LAYER BY CAPACITANCE-VOLTAGE MEASUREMENTS WITH AN EVAPORATED METAL SCHOTTKY DIODE

6 Subcommittee & Task Force Reports

6.1 International Advanced Wafer Geometry Task Force

6.2 International/ Japan Test Method Task Force

6.3 International Advanced Surface Inspection Task Force

6.4 International Polished Wafers Task Force

6.5 International Epitaxial Wafers Task Force

6.6 International Annealed Wafers Task Force

6.7 International SOI Wafers Task Force

7 Old Business

7.1 Project Period Review

- SNARF 6702. Revision of SEMI M60: TEST METHOD FOR TIME DEPENDENT DIELECTRIC BREAKDOWN CHARACTERISTICS OF Amorphous SiO2 FILMS FOR Silicon WAFER EVALUATION

7.2 5-year Review

- SEMI M77-1015 (Reapproved 0421), Test Method for Determining Wafer Near-Edge Geometry Using Roll-Off Amount, ROA

8 New Business

9 Action Item Review

9.1 Open Action Items

Item #	*Assigned to*	*Details*
SW20260417-02	Ryuji Takeda	To bring up the Int'l Terminology TF co-leader absence issue to the Silicon Wafer GCS.
SW20260417-03	Int'l. AWG TF leader	To prepare SNARFs for Line Item Revision to SEMI M67 and M68.
SW20260828-01	SEMI Staff	To forward the ballot adjudication results of Doc.#7468 to the ISC A&R SC for procedural review.

9.2 New Action Items

Item #	*Assigned to*	*Details*

10 Next Meeting and Adjournment

10.1 The next meeting is scheduled for <date> at <event/location>.